

L Number	Hits	Search Text	DB	Time stamp
-	573	349/155 and method	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 14:18
-	313	349/156 and method	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 14:15
-	48	mask same (non adj conductive) same (spacer or pillar or projection or protrusion or bead or ball or sphere)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 14:17
-	17	349/155 and (non adj conductive)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 14:19
-	10	349/156 and (non adj conductive)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 14:19
-	50	349/155 and SiO	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 15:09
-	20	349/155 and SiN	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 14:20
-	18	349/156 and SiO	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 14:20
-	0	349/156 and NiO	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 14:21
-	276	forming same (non adj conductive) same (spacer or bead or sphere or ball or pillar or protrusion ot projection)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 14:29
-	0	(349/155 and SiO) and (forming same (non adj conductive) same (spacer or bead or sphere or ball or pillar or protrusion ot projection))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 14:27
-	0	(349/155 and SiN) AND (forming same (non adj conductive) same (spacer or bead or sphere or ball or pillar or protrusion ot projection))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 14:27
-	0	(349/156 and SiO) and (forming same (non adj conductive) same (spacer or bead or sphere or ball or pillar or protrusion ot projection))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 14:27
-	2	(349/155 and method) and (forming same (non adj conductive) same (spacer or bead or sphere or ball or pillar or protrusion ot projection))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 14:27

-	4	349/155 and (non adj pixel adj (area or region))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 14:36
-	23	(non adj conductive adj (layer or film or material or sheet or laminate)) same (pixel)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 14:44
-	1162	(forming or coating) same transparent same (non-adj conductive) same (pixel)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 14:55
-	606	(forming or coating) same transparent same (non-adj conductive) same (spacer or pillar or sphere or projection or protrusion or bead or ball)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 14:50
-	49	((forming or coating) same transparent same (non-adj conductive) same (pixel)) and ((forming or coating) same transparent same (non-adj conductive) same (spacer or pillar or sphere or projection or protrusion or bead or ball))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 14:50
-	2	(forming or coating) same transparent same (non adj conductive) same (pixel)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 14:56
-	0	forming same (spacers) same (non adj conductive adj material) same (non adj pixel adj area)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 14:57
-	0	forming same (spacers or pillars or projections or protrusions or beads or balls or spheres) same (non adj conductive adj material) same (non adj pixel adj area)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 14:58
-	317	(photolithographic or photolithography or mask) and 349/155	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 15:02
-	4	(non adj pixel adj (area or region)) and 349/155	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 15:03
-	4	((photolithographic or photolithography or mask) and 349/155) and ((non adj pixel adj (area or region)) and 349/155)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 15:08
-	0	349/155 and (non adj conductive adj (film or layer or sheet))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 15:10
-	0	349/156 and (non adj conductive adj (film or layer or sheet))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 15:11
-	5842	(spacer or bead or pillar or projection or protrusion or ball or sphere or particle) same (SiO or SiN)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 15:14

-	20	349/155 and ((spacer or bead or pillar or projection or protrusion or ball or sphere or particle) same (SiO or SiN))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 15:19
-	4	349/156 and ((spacer or bead or pillar or projection or protrusion or ball or sphere or particle) same (SiO or SiN))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 15:29
-	72	substrate same (non adj pixel adj (area or region))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 15:31
-	6	(forming or coating or covering) same (non adj conductive adj (layer or material or film or sheet)) same pixel	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 15:35
-	449	(forming or coating) same (non adj conductive adj (material or layer or film or sheet)) same substrate	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 15:39
-	8	mask same (non adj pixel adj (area or region))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 16:36
-	4173	(photolithographic or photolithography or lithography or lithographic) same (spacer or projection or protrusion or bead or sphere or pillar or column or support or ball) same (non adj pixel (area or region))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 15:50
-	2	(photolithographic or photolithography or lithography or lithographic) same (spacer or projection or protrusion or bead or sphere or pillar or column or support or ball) same (non adj pixel adj (area or region))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 15:52
-	208	349/155 and (photolithographic or photolithography or lithographic or lithography)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 15:53
-	179	349/156 and (photolithographic or photolithography or lithographic or lithography)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 15:53
-	4	349/155 and (non adj pixel adj (area or region))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 15:54
-	4	349/155 and (non adj pixel adj (area or region or unit))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 15:55
-	3	349/156 and (non adj pixel adj (area or region or unit))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 15:56

-	85	(349/155 and (photolithographic or photolithography or lithographic or lithography)) and (349/156 and (photolithographic or photolithography or lithographic or lithography))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 16:24
-	1	(349/155 and (non adj pixel adj (area or region or unit))) and (349/156 and (non adj pixel adj (area or region or unit)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 15:57
-	0	((349/155 and (photolithographic or photolithography or lithographic or lithography)) and (349/156 and (photolithographic or photolithography or lithographic or lithography))) and ((349/155 and (non adj pixel adj (area or region or unit))) and (349/156 and (non adj pixel adj (area or region or unit))))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 15:57
-	0	(lithographic or lithography) same spacer same (non adj pixel)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 16:10
-	0	(lithographic or lithography) near10 spacer near10 (non adj pixel)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 16:10
-	0	(lithographic or lithography) near10 (non adj conductive) near10 (non adj pixel)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 16:11
-	0	(lithographic or lithography) same (non adj conductive) same (non adj pixel)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 16:12
-	12	(lithographic or lithography) same (non adj conductive) same (spacer or column or support or projection or protrusion or pillar or bead or sphere or bead or ball)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 16:13
-	199	349/155 and etching	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 16:25
-	158	349/156 and etching	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 16:25
-	71	(349/155 and etching) and (349/156 and etching)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 16:25
-	6	((349/155 and etching) and (349/156 and etching)) and (349/155 and SiO)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 16:26
-	3	((349/155 and etching) and (349/156 and etching)) and (349/155 and SiN)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 16:26

-	6	((349/155 and etching) and (349/156 and etching)) and (349/156 and SiO)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 16:26
-	2	((349/155 and etching) and (349/156 and etching)) and (349/155 and SiO)) and ((349/155 and etching) and (349/156 and etching)) and (349/155 and SiN)) and ((349/155 and etching) and (349/156 and etching)) and (349/156 and SiO))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 16:26
-	1	6552770.did.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 16:38
-	620	(photolithography or photolithographic or lithography or lithographic) same transparent same (spacer or column or projection or protrusion or pillar or bead or sphere or ball)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 16:41
-	19	349/155 and ((photolithography or photolithographic or lithography or lithographic) same transparent same (spacer or column or projection or protrusion or pillar or bead or sphere or ball) )	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 16:41
-	20	349/156 and ((photolithography or photolithographic or lithography or lithographic) same transparent same (spacer or column or projection or protrusion or pillar or bead or sphere or ball) )	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 16:51
-	11	349/155 and (mask same shield)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 16:54
-	14	349/156 and (mask same shield)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 16:54
-	5	(349/155 and (mask same shield)) and (349/156 and (mask same shield))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 16:58
-	204	coating same dielectric same pixel	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 17:01
-	106	(non adj conductive) same (SiO or SiN)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 17:05
-	0	349/155 near10 SiN	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 17:06
-	0	349/156 near10 SiN	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/13 17:06

-	8	(photolithography or photolithographic or lithography or lithographic) same (microdisplay or (micro adj display) or micro-display)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/05/13 17:07
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